

Electronic Patent Application Fee Transmittal

Application Number:	10813390			
Filing Date:	31-Mar-2004			
Title of Invention:	System and method of removing chamber residues from a plasma processing system in a dry cleaning process			
First Named Inventor/Applicant Name:	Marcel Gaudet			
Filer:	Marvin Jay Spivak/Sachie Fazzone			
Attorney Docket Number:	250312US6 YA			
Filed as Large Entity				
Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Notice of appeal	1401	1	510	510
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension - 1 month with \$0 paid	1251	1	120	120
Miscellaneous:				
Total in USD (\$)				630